



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. 10/581,247

Group: Unknown

Filed: May 31, 2006

Examiner: Unknown

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREFOR

\* \* \* \* \*

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

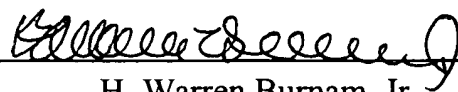
Sir:

**STATUS INQUIRY**

A national phase application was filed on May 31, 2006. However, since then applicant has not received the **Notice of Acceptance and Official Filing Receipt** from the Patent Office regarding the application. Inquiry is made as to when the **Notice of Acceptance and Official Filing Receipt** be forthcoming. **Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.**

Respectfully submitted,  
**NIXON & VANDERHYE P.C.**

November 30, 2006

By: 

H. Warren Burnam, Jr.

Reg. No. 29,366

HWB:lsh  
901 North Glebe Road, 11th Floor  
Arlington, VA 22203-1808  
Telephone: (703) 816-4000  
Facsimile: (703) 816-4100